

<b>Notice of References Cited</b>	Application/Control No. 10/558,917		Applicant(s)/Patent Under Reexamination WONG ET AL.	
	Examiner KEVIN M. JOHNSON		Art Unit 1793	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,439,865 A	08-1995	Abe et al.	502/333
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Brinker et al., Evaporation-Induced Self-Assembly: Nanostructures Made Easy, 1999, Advanced Materials, 11, No. 7, p 579-585.
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	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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